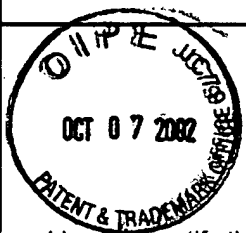


2815

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)			Docket No. 90065.001020/8011.00
Applicant(s): Martin E. Kordesch, Howard D. Bartlow, Richard L. Woodin			
Serial No. 09/682,151	Filing Date 27 July 2001	Examiner Chris C. Chu	Group Art Unit 2815
Invention: CONTACT METHOD FOR THIN SILICON CARBIDE EPITAXIAL LAYER AND SEMICONDUCTOR DEVICES FORMED BY THOSE METHODS			
<div><div>RECEIVED OCT - 9 2002 TECHNOLOGY CENTER 2800</div></div> <p>I hereby certify that this <u>Response to Office Action</u> <i>(Identify type of correspondence)</i></p> <p>is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The Assistant Commissioner for Patents, Washington, D.C. 20231 on <u>October 1, 2002</u> <i>(Date)</i></p> <p><u>Kathleen A. Manczuk</u> <i>(Typed or Printed Name of Person Mailing Correspondence)</i></p> <p><u>Kathleen A. Manczuk</u> <i>(Signature of Person Mailing Correspondence)</i></p> <p>Note: Each paper must have its own certificate of mailing.</p>			

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